

Transaction Information

Tool ID	OXDW-A01
Tool Status	Running Wafers
Location	Woodlands, Singapore
Wafer Size	200 mm
Fab Section	Clean
Tool Available Date	2022-12-31

General Product Information

Vendor Supplier	SANKYO
Model	WH80
Vintage	1996
Serial No	NA
Asset Description	CT0011
Software Version	REV1.0
CIM	GEM
Process	OXIDE ETCH

Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Main System	Verteq SRD	1	OK
Main System	Main Frame	1	OK
Main System	Chuck Clean Bath (PVC)	1	OK
Main System	Touch Panel	1	OK
Main System	Chemical Bath (PTFE)	4	OK
Main System	Circulation Pump, Damper, Heat Exchanger	4	OK
Main System	Main Frame	1	OK
Main System	Gem Controller	1	OK
Main System	F/R Bath (Quartz)	1	OK
Main System	O/F Bath (Quartz)	2	OK
Main System	Circulation line, Valves, Filter housing	4	OK
Main System	System PC Set	1	OK
Handler System	Wafer transfer system	2	OK
Handler System	Stocker Robot	2	OK
Handler System	Transfer Robot	3	OK
Handler System	Transporter	1	OK
Factory Interface	SMIF	2	OK
Factory Interface	...		OK
Options System			
Others			

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
Transformer	1	OK
UPS	1	OK

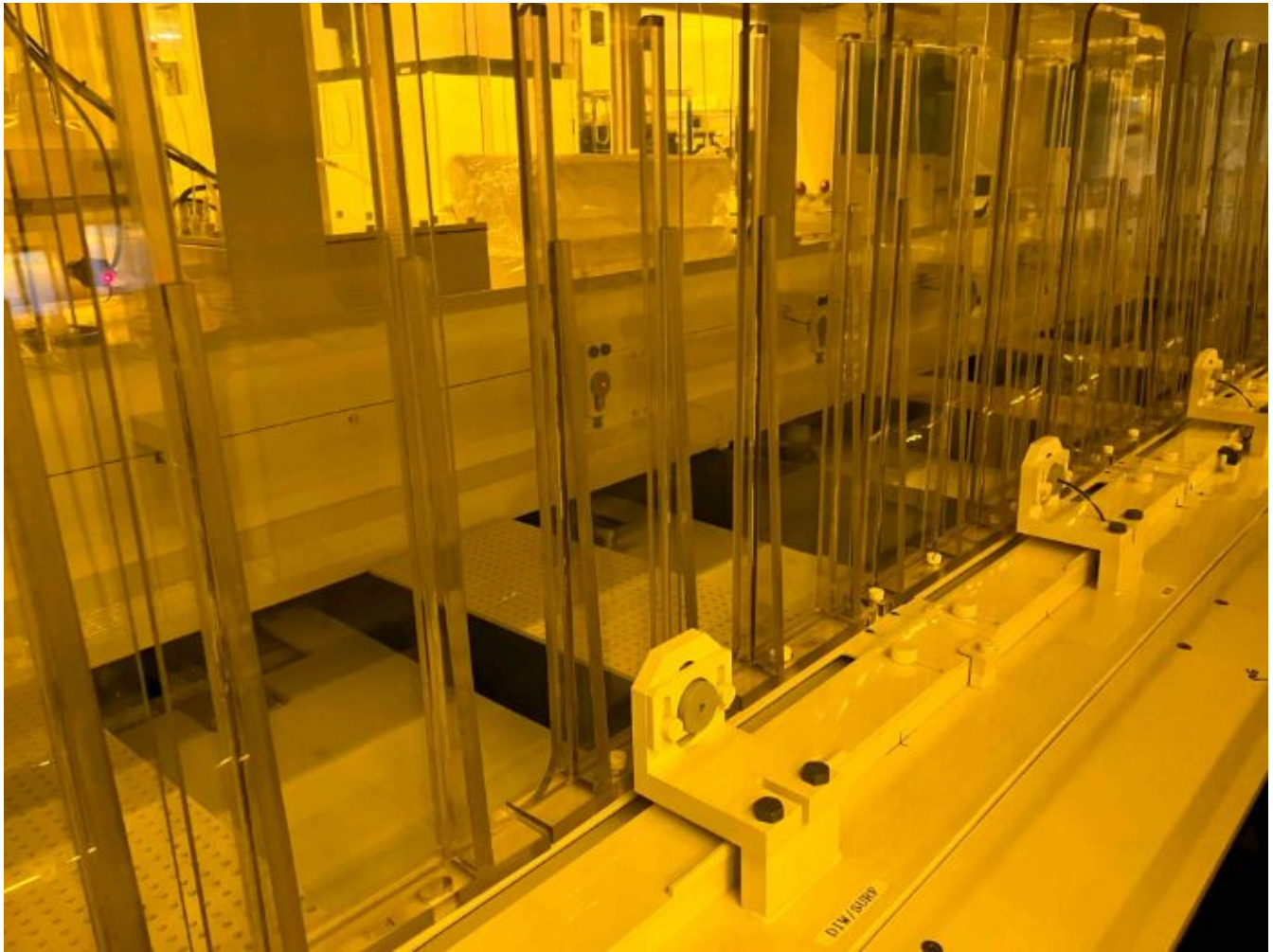
Missing/Faulty Parts / Accesories List

Description	Quantity
NONE	

Tool Pictures

General

Main tool



General

Main tool



General

Main tool



General

Main tool



General

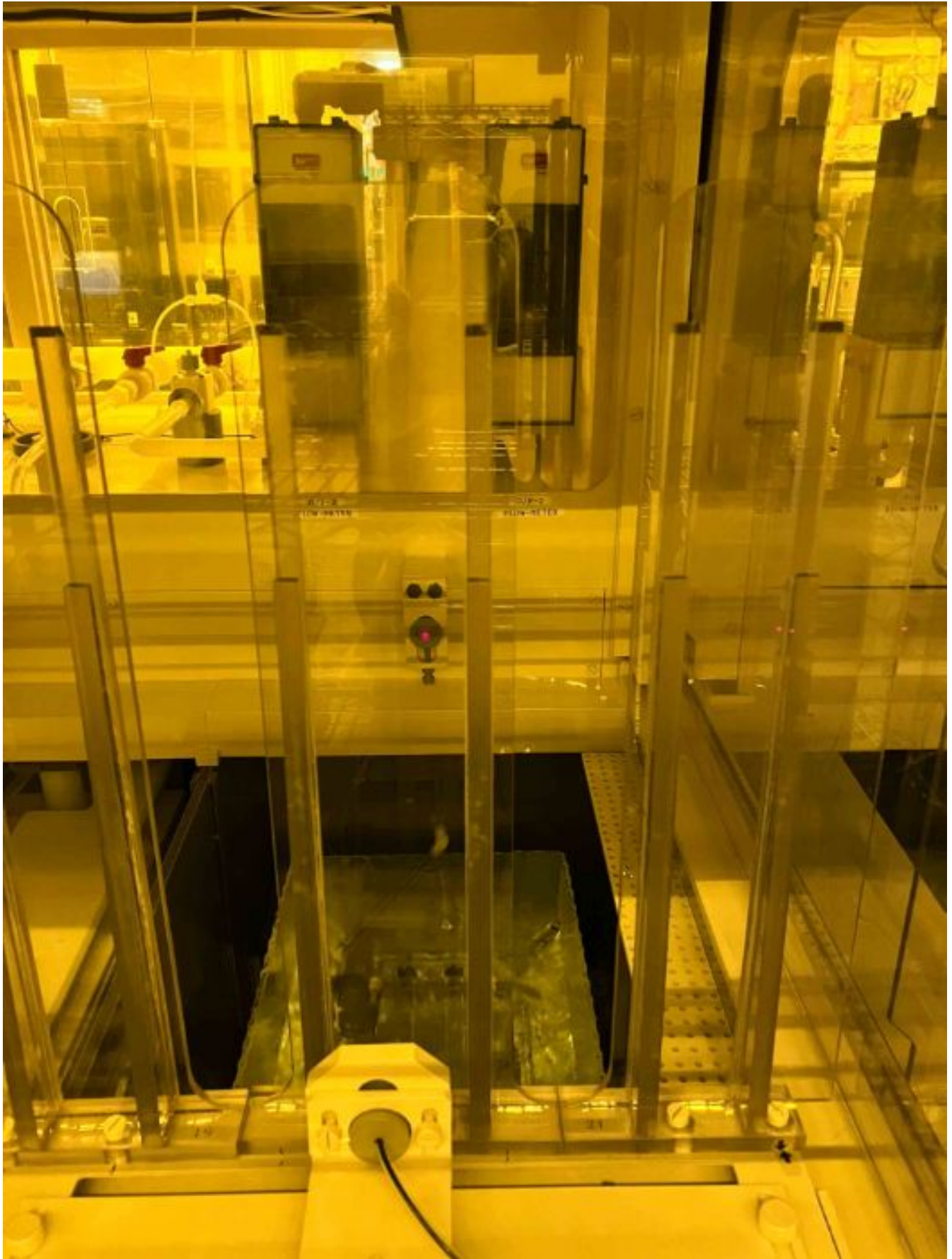
Main tool

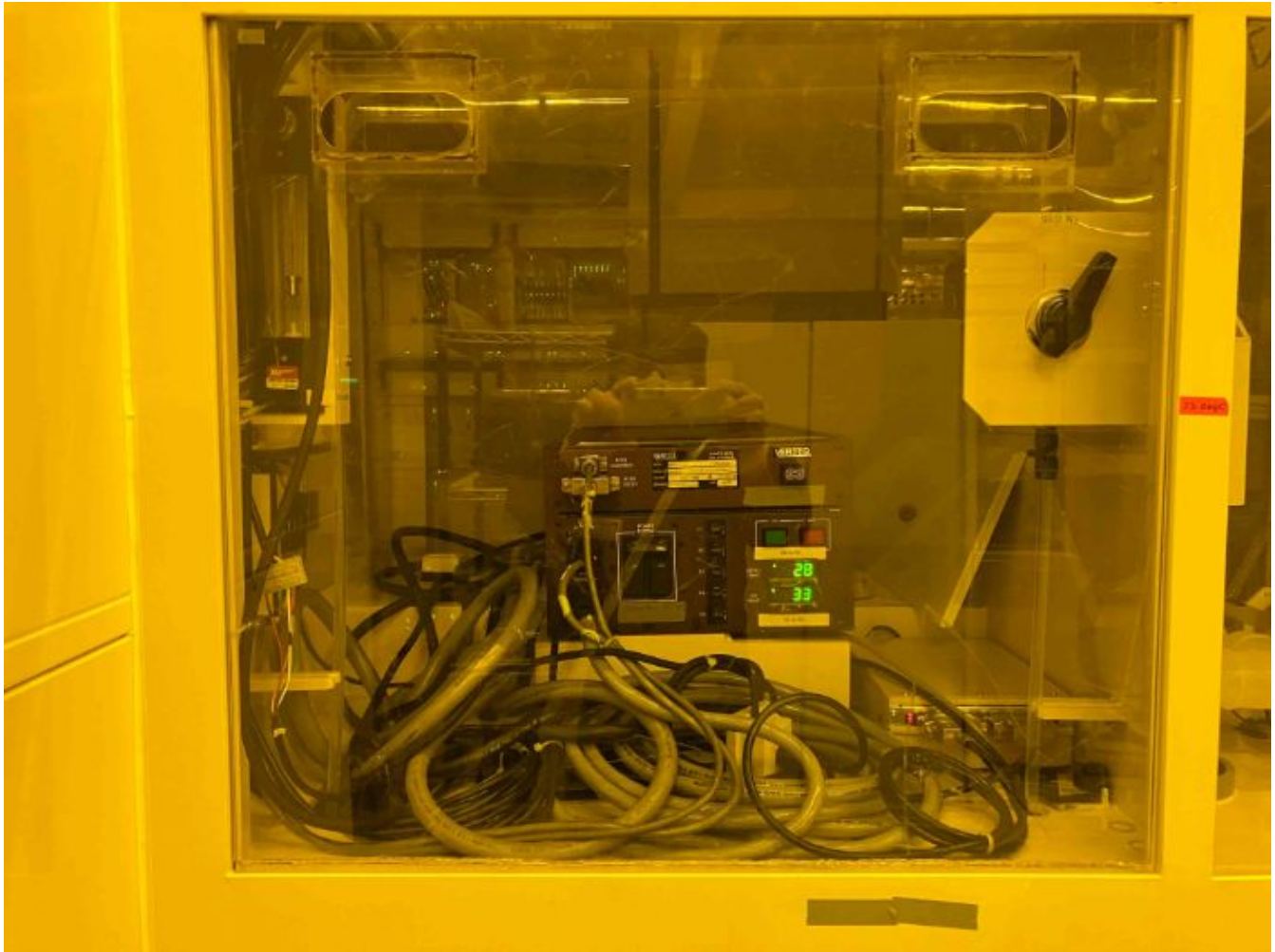


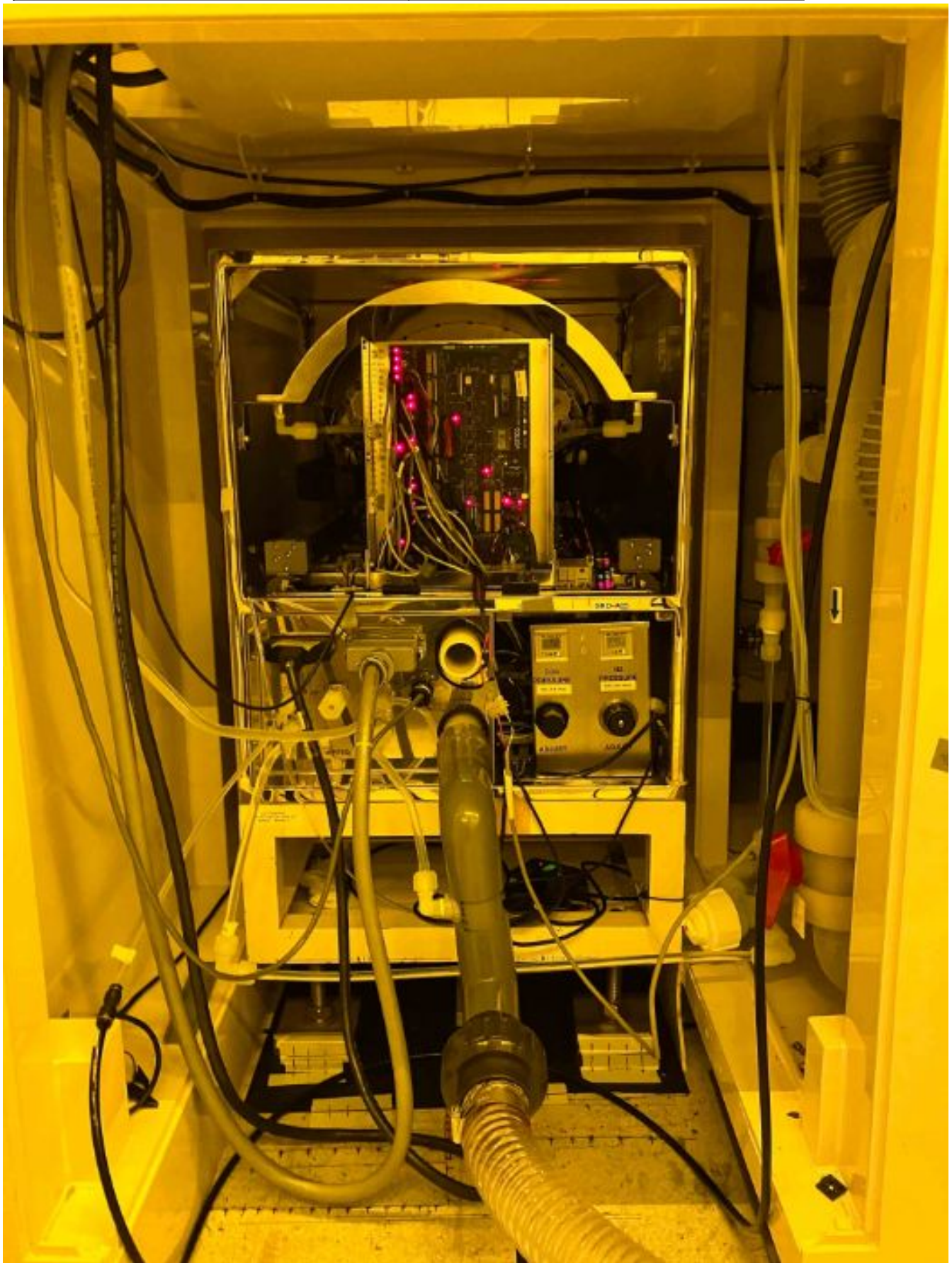
General

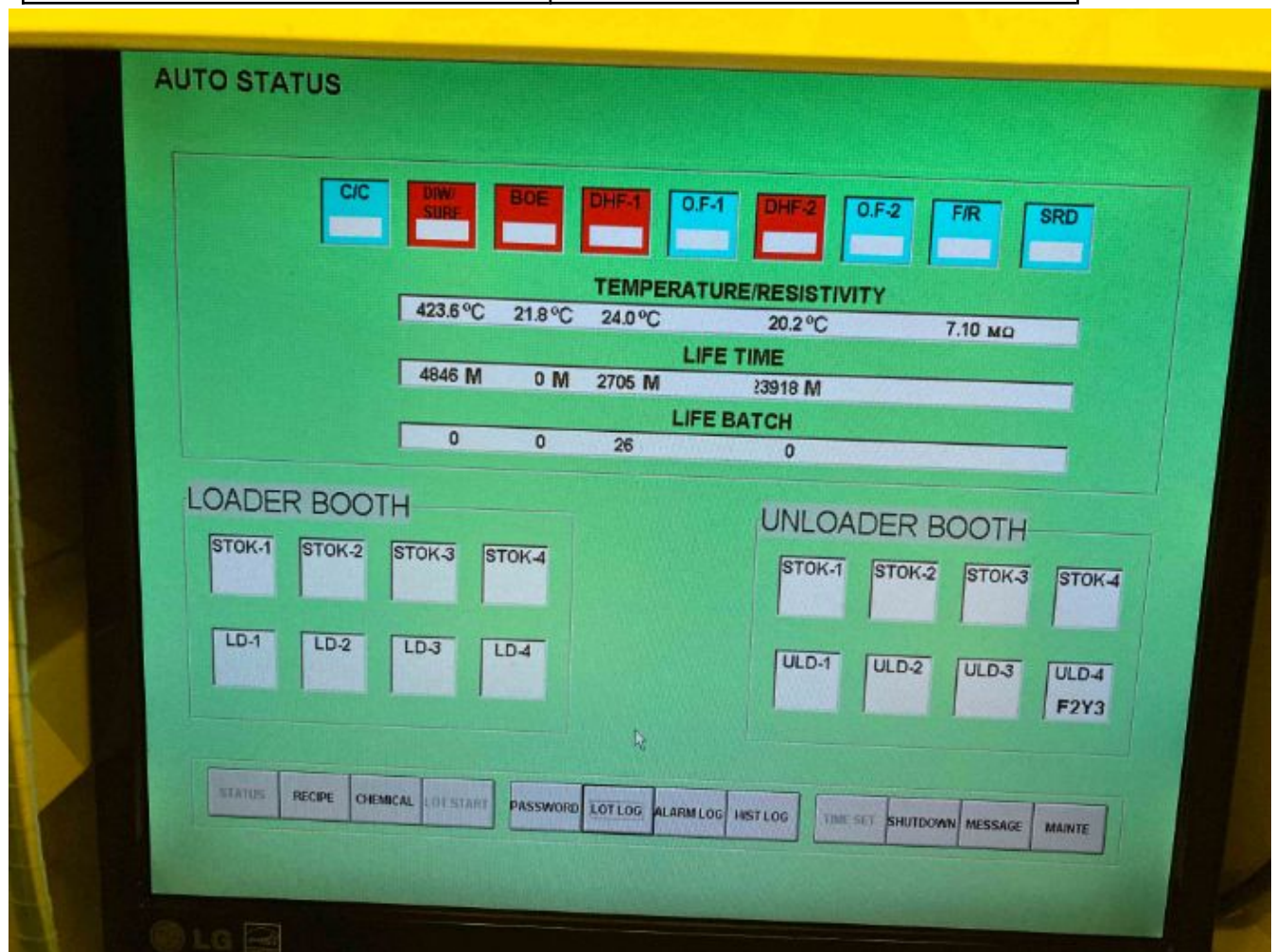
Main tool











Additional Configuration Files